## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Application of: |   | PATENT APPLICATION              |
|-----------------------|---|---------------------------------|
| Inventors:            | Apostolos Voutsas, Yukihiko Nakata and Takeshi Hosoda   |                                 |
| Serial No.:           | Not Yet Assigned )  | Attorney Docket No.<br>SLA 0468 |
| Filed:                | Herewith )  |                                 |
| Title:                | A SEMICONDUCTOR DEVICE ) AND A METHOD OF CREATING ) THE SAME UTILIZING METAL ) INDUCED CRYSTALLIZATION ) WHILE SUPPRESSING PARTIAL; SOLID PHASE CRYSTALLI- ZATION ) |                                 |

Hon. Assistant Commissioner for Patents Washington, D.C. 20231

## INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Sir:

Listed on attached Form PTO-1449 is information submitted pursuant to 37 C.F.R. §1.56. A copy of each listed publication is submitted herewith.

Applicant respectfully requests that the listed information be considered by the Examiner and made of record in the above-identified application.

(Date)

Respectfully sulpmitted

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Disclosure SLA0468